

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 13, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG671455784

LABORATORY GROWN DIAMOND

EMERALD CUT

8.57 X 6.02 X 4.05 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

2.09 CARATS

F

VS 1

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry


Fluorescence

Inscription(s)

EXCELLENT


EXCELLENT

NONE

 LG671455784

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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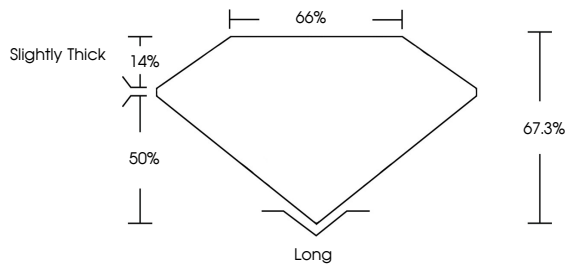
EXCELLENT

NONE

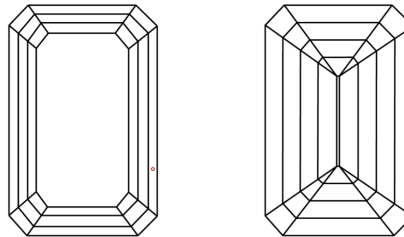
 LG671455784

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PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY



IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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EMERALD CUT

8.57 X 6.02 X 4.05 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

2.09 CARATS

F

VS 1

EXCELLENT

67.3%

66%


Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

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